

TiO₂ Thin Films Synthesized by the Spray Pyrolysis Deposition (SPD) Technique

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Abstract

Anatase-type TiO₂ thin films with high transmittance (>70%) in the visible region were successfully synthesized on glass substrates by the spray pyrolysis deposition (SPD) technique. Two kinds of starting solutions; TiCl₄ ethanol solution and Ti(*i*-OC₃H₇)₄ 2-propanol solution with TiCl₄ as an additive were prepared separately. The TiO₂ thin film obtained from the former solution showed the preferred orientation along the [101] direction. However, a 1.5 μm thick film from the latter solution revealed almost the same transmittance as a 200 nm thick film from the former. The result indicates that the complexes produced by adding TiCl₄ in Ti(*i*-OC₃H₇)₄ 2-propanol solution plays an important role in the mechanism of the crystallization of TiO₂. © 1999 Elsevier Science Limited. All rights reserved

Keywords: films, electron microscopy, grain size, optical property, TiO₂.

1 Introduction

Titanium dioxide (TiO₂) has been one of the most attractive materials in the experimental investigation during the last decades due to its scientific and technological importance. For example, the electrochemical photolysis of water with TiO₂ was intensively studied as a candidate for a new energy source.¹ Sterilization² and sewage disposal³ using TiO₂ as an electrochemical catalyst were also investigated. A current topic is a new electrochemical solar cell with high conversion efficiency.⁴ Anatase-type TiO₂ thin film was employed for the cell as a working electrode, and then the improvement of the film preparation technique is required. Among many processing techniques, the spray

pyrolysis deposition (SPD) technique is one of the most promising ones, since the structure of the apparatus is quite simple and the technique is applicable to produce thin films on a large scale. We have already succeeded in the syntheses of SnO₂,⁵ Sn₂OS⁶ and Cu₂O⁷ thin films by this technique. In the present work, we have developed this technique to TiO₂ thin film preparation.

In this paper, we report anatase-type TiO₂ thin film synthesis by the SPD technique using titanium tetrachloride (TiCl₄) and titanium tetraisopropoxide [Ti(*i*-OC₃H₇)₄] as starting solutions. We found that the surface morphology of the film thus obtained strongly depends on the starting solutions.

2 Experimental

Two kinds of starting solutions; 0.5 wt% of TiCl₄ (99%, Wako Pure Chemical Industries Ltd.) ethanol solution and 0.5 wt% of Ti(*i*-OC₃H₇)₄ (95%, Wako Pure Chemical Industries Ltd.) 2-propanol solution with an additive of TiCl₄ with a molar ratio of Ti(*i*-OC₃H₇)₄/TiCl₄ = 1 to prevent the hydrolysis with moisture from the air were prepared.

The apparatus used for the spray pyrolysis was described elsewhere.^{5–7} After setting up the spray gun (Lumina STA-6R-1 mmφ, Fuso Seiki Co. Ltd.) approximately 30 cm above the glass substrate (25×25×1 mm³ in size; Corning 7059) on the holder, the substrate was heated up between 300 and 450°C, and then the pyrolysis procedure was initiated using 2.3 kg/cm² of compressed air or pure oxygen gas as a carrier gas. Since the sprayed mist cooled down the substrate, the period and the volume of the solution for each spraying was fixed at 1.0 s and 1.0 ml, respectively. After recovering the substrate temperature, the same pyrolysis procedure was carried out again. Each procedure was then repeated 200 times for one substrate.

The crystal structure of the film was determined by XRD using CuK_α radiation (Rigaku Rint-2000).

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The transmittance in the visible region was measured by the spectrophotometer (Jasco V-570). The surface morphology was observed by FE-SEM (JSM-6320F, JEOL). The film porosity was evaluated from the water adsorption.

3 Results and Discussion

3.1 TiCl_4 ethanol solution

Figure 1 shows the XRD patterns of TiO_2 thin films deposited at various substrate temperatures from TiCl_4 ethanol solution using compressed air (a) or pure oxygen gas (b) as a carrier gas. In both cases, the TiO_2 thin films thus obtained revealed several crystalline structures from amorphous to anatase and then to rutile with increasing substrate temperature. Anatase single phase was obtained between 350 and 380°C with air, while the anatase single phase region was spread between 350 and 430°C with pure oxygen gas. The result contradicts the observation that rutile is more stable than anatase in an oxygen atmosphere. However, the fluorescent X-ray analysis detected a slight trace of residual chlorine in all anatase structure films. We suppose the residual chlorine is related to the stability of anatase structure in an oxygen atmosphere, although the detail of the mechanism is not clarified.

Figure 2(a) shows the SEM image of the surface morphology of anatase-type TiO_2 thin film with the thickness of 200 nm deposited at 380°C with air. The film surface consists of many platelets, being 300 nm in length and 20–30 nm in width, arranged in a porous microstructure. According to the XRD patterns shown in Fig. 1, the platelets are believed to be oriented along the [101] direction. In case of SnO_2 thin film deposited by SPD technique, the orientation along the [200] direction was

explained by the molecular association between the solvent, ethanol and the raw material, di-n-butyltin diacetate (DBTDA).⁵ We suppose our result is related to the association between ethanol and TiCl_4 . However, since TiCl_4 shows much smaller polarity due to its symmetrical molecular structure

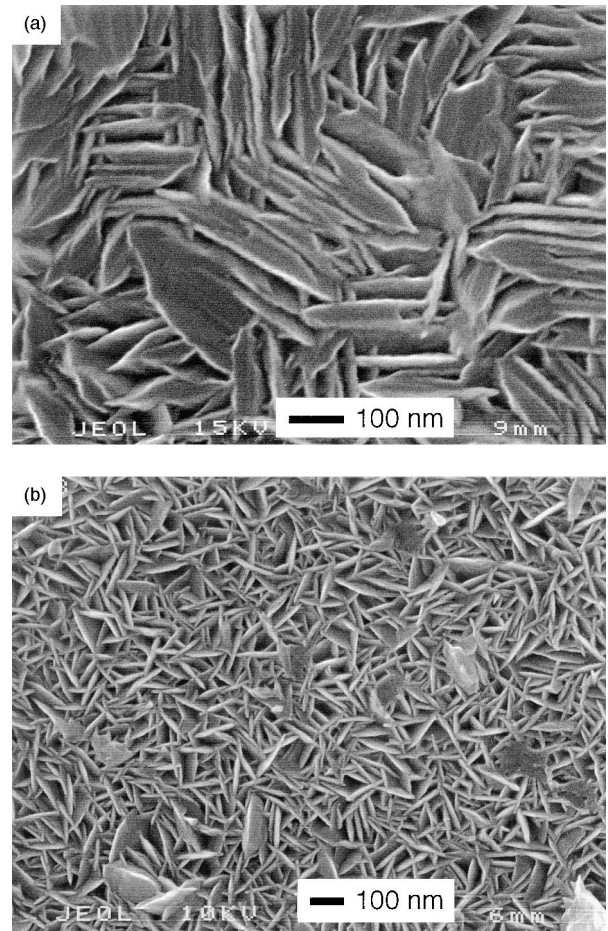


Fig. 2. SEM image of the surface morphology of TiO_2 thin film deposited with compressed air (a) from TiCl_4 ethanol solution at the substrate temperature of 380°C and (b) from $\text{Ti}(\text{i-OC}_3\text{H}_7)_4$ 2-propanol solution with the additive of TiCl_4 at 430°C.

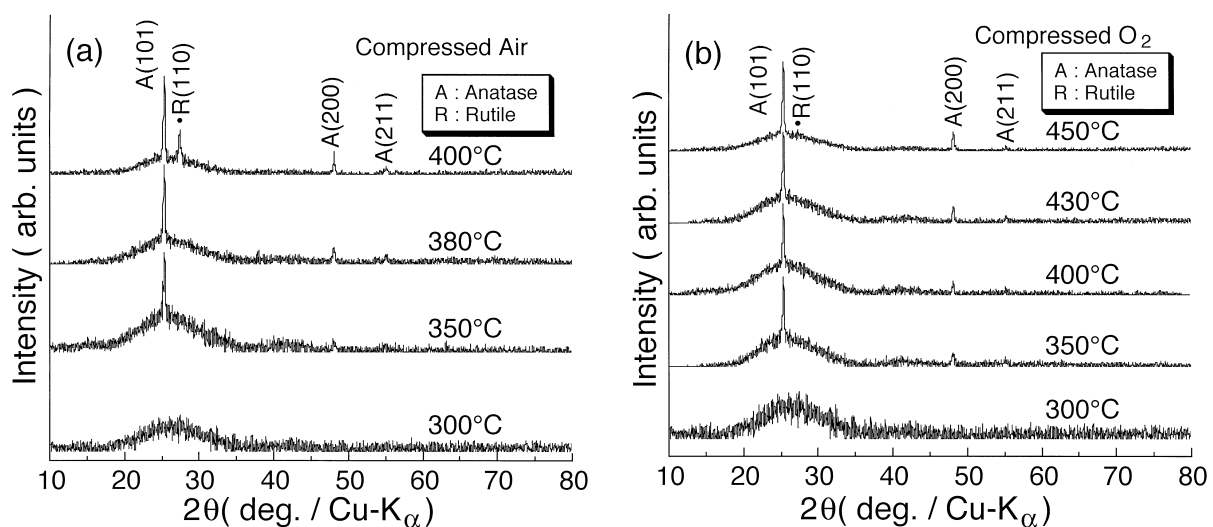


Fig. 1. XRD patterns of TiO_2 thin films deposited at various substrate temperature from TiCl_4 ethanol solution: (a) compressed air and (b) pure oxygen gas was used as a carrier gas. A and R corresponds to anatase and rutile, respectively.

comparing with DBTDA, the association between TiCl₄ and ethanol is not so strong as that between DBTDA and ethanol. This is the reason why the TiO₂ thin film obtained here is not so highly oriented as SnO₂.

Figure 3 shows the transmittance spectra of the 200 nm thick TiO₂ thin films deposited with compressed air at 380°C (sample A) and pure oxygen gas at 430°C (sample B). The transmittance spectrum of the glass substrate is also shown as a reference. The average transmittance in the visible region (400–800 nm) was evaluated to be 73, 77 and 89% for samples A, B and the glass substrate, respectively. Both samples A and B show enough transmittance for their practical applications, while there are only a few interference fringes, indicating the relatively rough surface structure. This result corresponds to the SEM image in Fig. 2(a).

3.2 Ti(*i*-OC₃H₇)₄ 2-propanol solution with TiCl₄ additive

There are two merits in dissolving TiCl₄ in Ti(*i*-OC₃H₇)₄ 2-propanol solution. One is that Ti(*i*-OC₃H₇)₄ and TiCl₄ are known to form [Ti(*i*-OC₃H₇)_{4-x}Cl_x]_n complexes, which exhibit a lower sensitivity towards hydrolysis and show high solubility in organic solvent.⁸ Another is that both Ti(*i*-OC₃H₇)₄ and TiCl₄ contain titanium ion, corresponding to the higher titanium ion concentration than the nominal one. The solution is then more favorable to deposit a thick film than the TiCl₄ ethanol solution discussed in the previous section.

Figure 4 shows the XRD patterns of TiO₂ thin films deposited at various substrate temperatures

from Ti(*i*-OC₃H₇)₄ 2-propanol solution with TiCl₄ stabilizer using compressed air as a carrier gas. Anatase single phase was obtained at substrate temperatures between 350 and 430°C. Many peaks corresponding to the anatase structure appeared with increasing temperature without any preferred orientation.

Figure 2(b) shows the SEM image of the surface morphology of TiO₂ thin film with the thickness of 1.5 μm deposited at 430°C with compressed air. This film is made up of platelets, approximately 100 nm in length and 10 nm in width. The volume in the film is calculated to be approximately 0.15 cm³ g⁻¹, thus the film porosity is about 37%. The surface morphology of the film is similar to that obtained from TiCl₄ ethanol solution, while the size of platelets is smaller than that in Fig. 2(a). The platelet structure observed here is supposed to be relevant to TiCl₄ derived from the decomposition of [Ti(*i*-OC₃H₇)_{4-x}Cl_x]_n complexes on the substrate. This is explained by the fact that the morphology of the TiO₂ particles in the film changes from platelet to granular when 2-octanol is used as a solvent. Since 2-octanol has a much higher boiling temperature than ethanol or 2-propanol, the reaction rate of [Ti(*i*-OC₃H₇)_{4-x}Cl_x]_n to TiCl₄ reduces in 2-octanol.

The dotted curve in Fig. 3 shows the transmittance spectrum of the 1.5 mm thick TiO₂ thin film. The average transmittance of the film is 71% in the range between 400 and 800 nm. The value is almost same as that deposited from TiCl₄ ethanol solution, although the film from Ti(*i*-OC₃H₇)₄ is approximately 8 times thicker than that from TiCl₄. However, the thicker film from Ti(*i*-OC₃H₇)₄ does not show many more interference fringes than the thinner films from TiCl₄. This is because of the low average index due to the porosity.

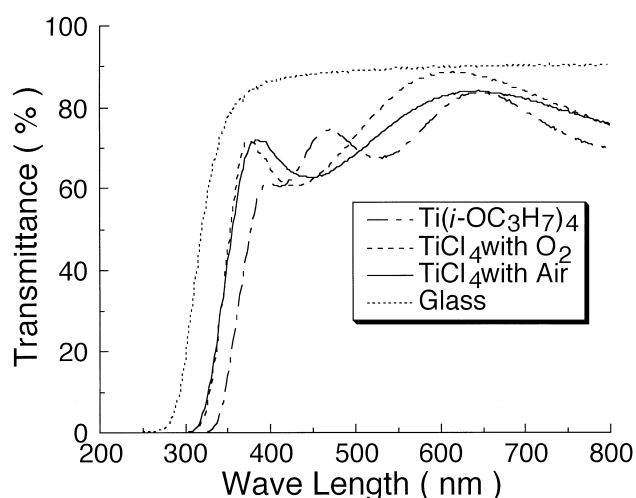


Fig. 3. Transmittance spectra of TiO₂ thin films as a function of wave length. The films were deposited from TiCl₄ ethanol solution at the substrate temperature of 380°C by compressed air (200 nm in thickness), at 430°C by compressed pure oxygen gas (200 nm in thickness), and from Ti(*i*-OC₃H₇)₄ 2-propanol solution with the additive of TiCl₄ at 430°C by compressed air (1.5 μm in thickness), respectively. The data of a glass substrate are shown as a reference.

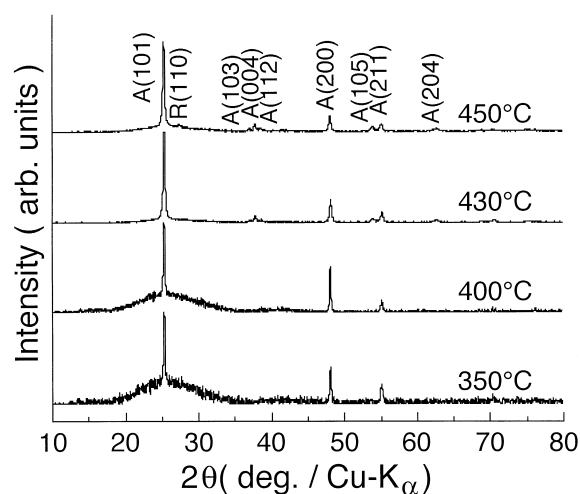


Fig. 4. XRD patterns of TiO₂ thin films deposited at various substrate temperature by compressed air from Ti(*i*-OC₃H₇)₄ 2-propanol solution with the additive of TiCl₄. A and R corresponds to anatase and rutile, respectively.

4 Conclusion

We have succeeded in synthesizing anatase-type TiO₂ thin films with high transmittance (> 70%) in the visible region on the glass substrate by the SPD technique. The film from TiCl₄ ethanol solution was consisted of platelets and showed the preferred orientation along the [101] direction, which is related to the molecular association between TiCl₄ and ethanol. On the other hand, the film from Ti(*i*-OC₃H₇)₄ together with TiCl₄ as a stabilizing agent showed scarcely the preferred orientation. However, the film with the thickness of 1.5 μm had the transmittance as high as 71% in the visible region, while the film did not show many more interference fringes than the thinner ones (200 nm) from TiCl₄ due to the porosity.

Acknowledgements

The authors are grateful to Associate Professor Kenji Murakami in Research Institute of Electro-

tics, Shizuoka University, for using FE-SEM and fruitful discussion.

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